

PATENT  
SAM435-100/00656  
Customer No.24,118

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: DONG-IL CHO )  
SERIAL NO: 09/614,785 )  
FILED: JULY 12, 2000 )  
FOR: SILICON ETCHING )  
APPARATUS USING  $\text{XeF}_2$  )  
ART UNIT: 1763 )  
EXAMINER: PARVIZ HASSANZADEH )

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PETITION FOR THREE-MONTH EXTENSION OF TIME


Assistant Director of Patents  
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR 1.136(a), Applicant hereby petitions for a three-month extension of time to respond to the Office Action dated August 28, 2002. Enclosed is a check in the amount of \$465 to cover the fee for the extension of time.

The Commissioner is authorized to charge any additional fees associated with this application or credit any overpayment to Deposit Account No. 08-1500.

Respectfully submitted,

  
Mark G. Kachigian  
Registration No. 32,840  
Head, Johnson & Kachigian  
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Attorneys for Applicant

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Date: February 26, 2003

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Director of Patents, Washington, D.C. 20231, on February 26, 2003.

